

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S38	15	(wafer or semiconductor or substrate or workpiece) same shield\$3 near10 blast\$3	EPO; JPO; DERWENT	OR	ON	2007/07/24 16:54
L2	102	(wafer or semiconductor or substrate or workpiece) same shield\$3 near10 blast\$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT	OR	ON	2007/07/24 16:54
L1	15	(wafer or semiconductor or substrate or workpiece) same shield\$3 near10 blast\$3	EPO; JPO; DERWENT	OR	ON	2007/07/24 16:54